

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Van Beek, *et al.* Docket No.: EPC-019
Serial No.: 10/578,026 Art Unit: 2829
Filed: March 13, 2007 Examiner: Ming Hung Hung
Title: Method of Manufacturing an Electronic Device and Electronic Device

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

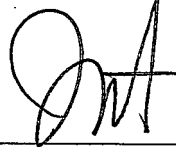
The Applicants wish to bring to the attention of the U.S. Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a which may be considered material to the examination of the above-identified application. A copy of the U.S. Patent cited is not being submitted. However, the Applicants have included a copy of the foreign patent.

This Information Disclosure Statement is submitted under 37 C.F.R. §1.97(c) together with a \$180.00 fee under 37 C.F.R. §1.17(p) after the C.F.R. §1.97(b) time period, but before final action or notice of allowance, whichever occurs first.

Please charge the required fee of \$180.00 and any additional amount, or credit any overpayment to Deposit Acct. No. 50-1065 of the below mentioned firm.

7/8/08
Date

Respectfully submitted,



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